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Fig. 1

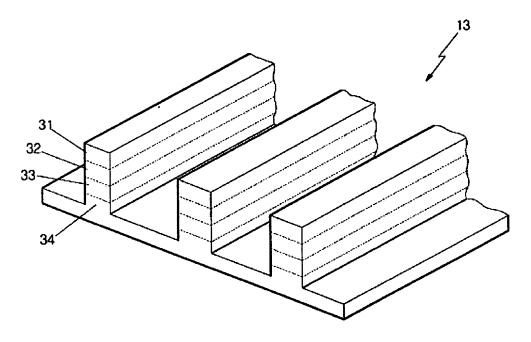


Fig. 2

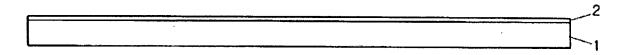
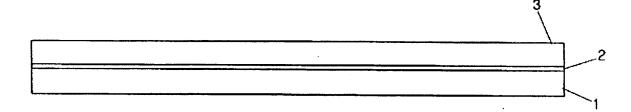


Fig. 3



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Fig. 4

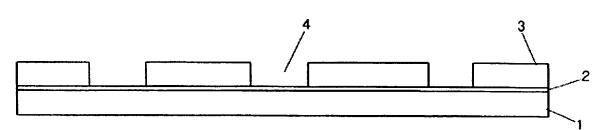


Fig. 5

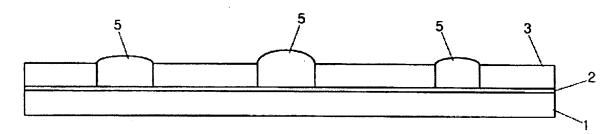


Fig. 6

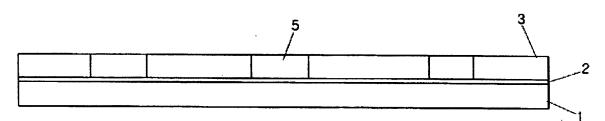
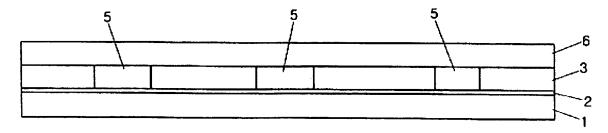


Fig. 7



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Fig. 8

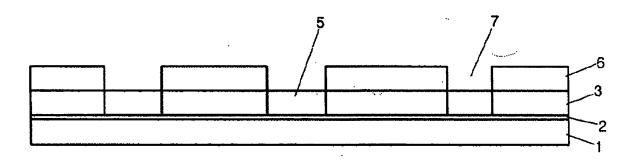


Fig. 9

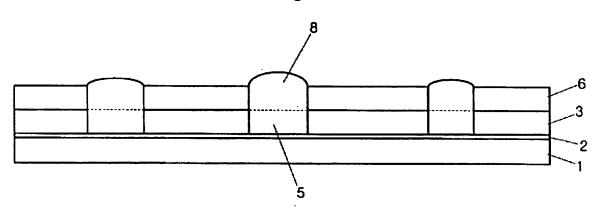
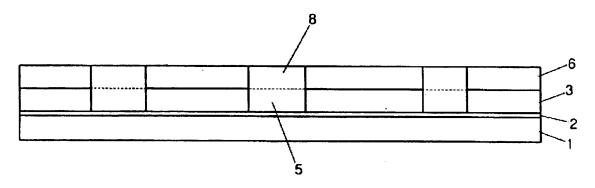


Fig. 10



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Fig. 11

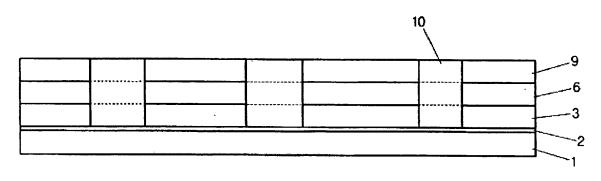


Fig. 12

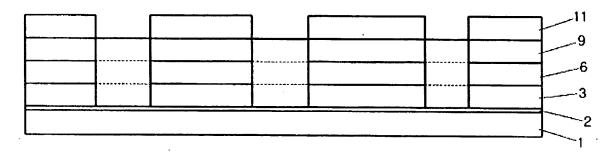
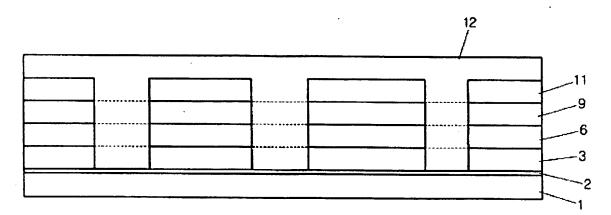


Fig. 13



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Fig. 14

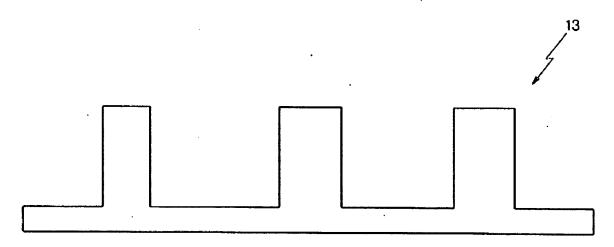
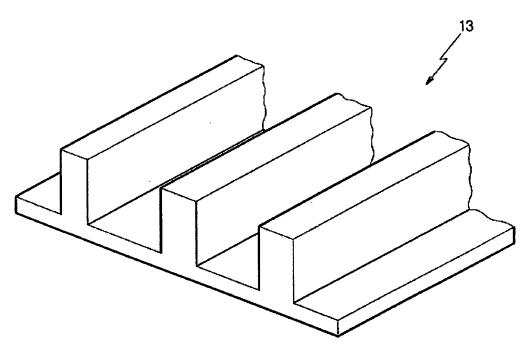


Fig. 15



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Fig. 16

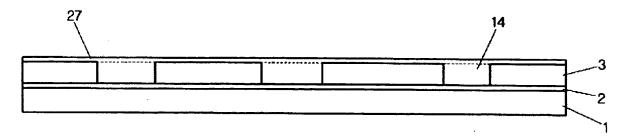


Fig. 17

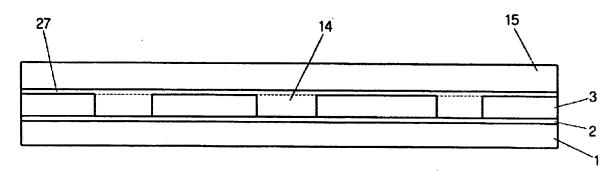
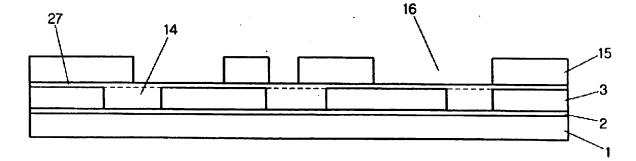


Fig. 18



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Fig. 19

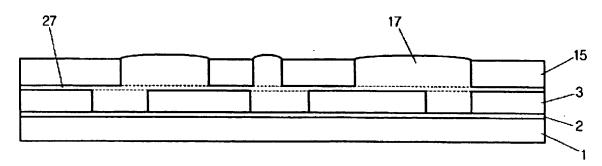


Fig. 20

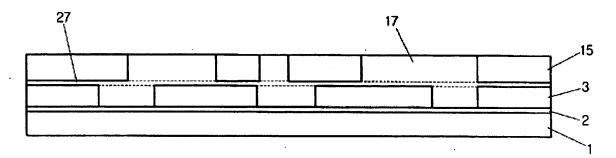
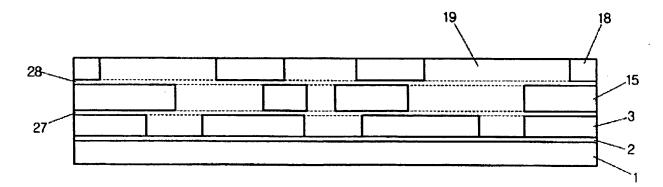


Fig. 21



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Fig. 22

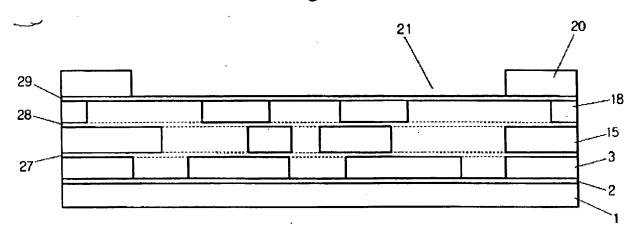
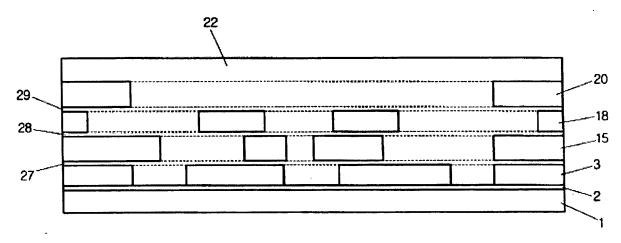
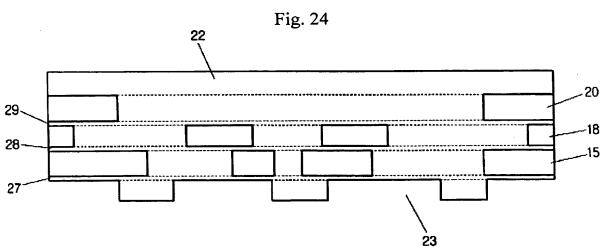


Fig. 23





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Fig. 25

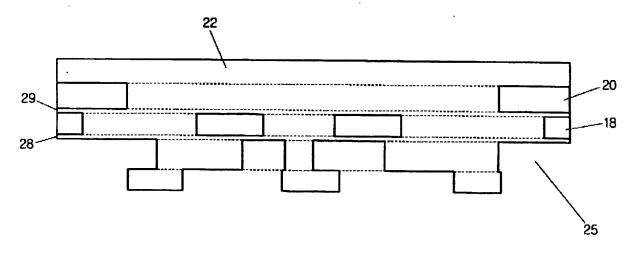


Fig. 26

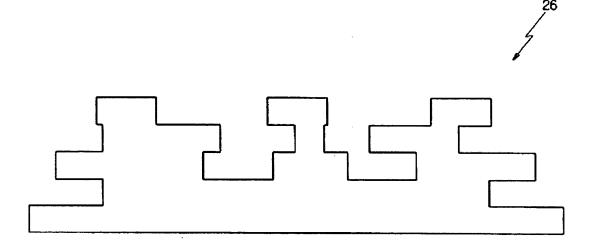
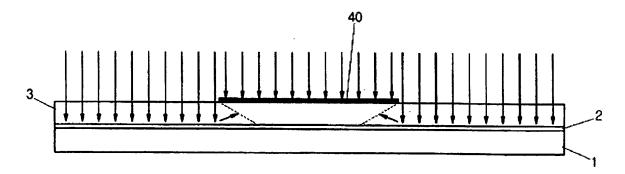


Fig. 27



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Fig. 28

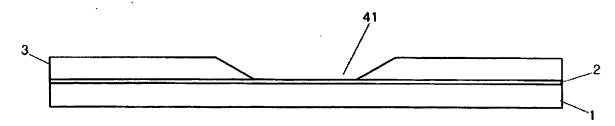


Fig. 29

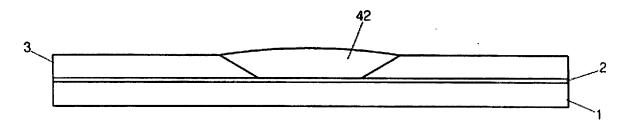


Fig. 30

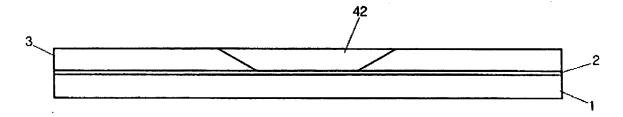
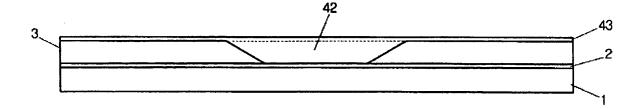


Fig. 31

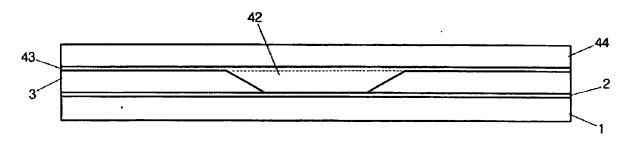


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Fig. 32



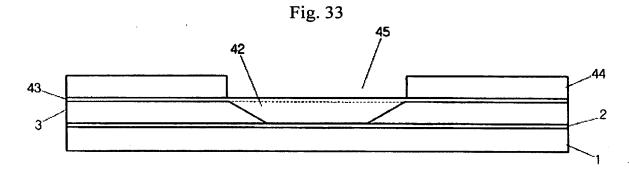


Fig. 34

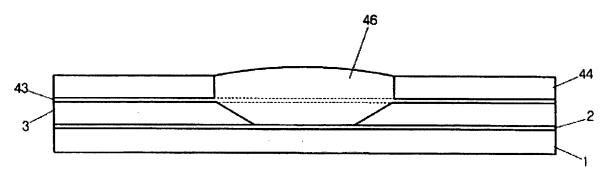
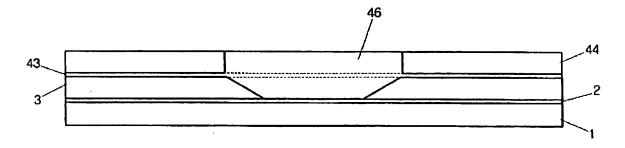


Fig. 35



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Fig. 36

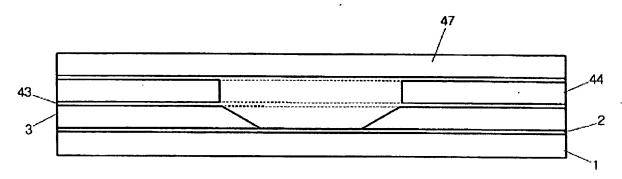


Fig. 37

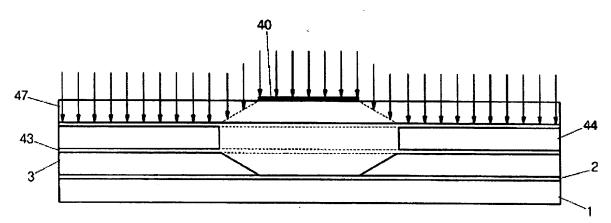
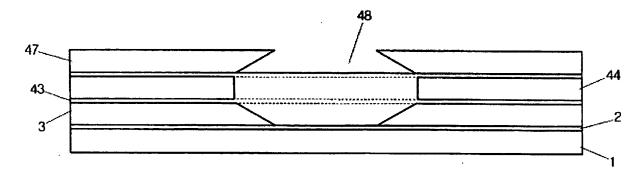


Fig. 38



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Fig. 39

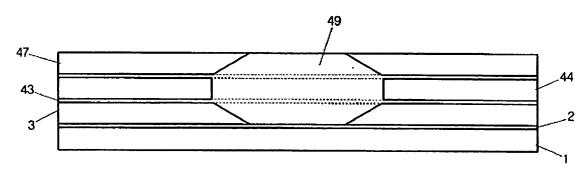
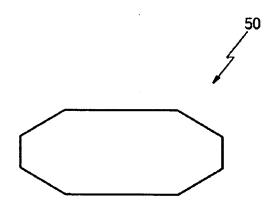


Fig. 40



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Fig. 41

